

APPLICANT'S INFORMATION
DISCLOSURE STATEMENT

Applicant: JOHN R. LEITZ

Serial No.: 09/774234

Filing Date: Herewith 1-31-01 Group: 1746

U.S. PATENT DOCUMENTS

OLSEN

Initial*	Document No.	Date	Name	Class	Subcl.	Filing Date
AA	1	1975	A Survey of Ion Beam Milling Techniques for Piezoelectric Device Fabrication			
AB						
AC						
AD						
AE						
AF						
AG						
AH						
AI						
AJ						
AK						

U.S. Pat. & Tm. Office
09/774234
01/31/01

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Class	Subcl.	Translation?
AL						
AM						
AN						
AO						
AP						

OTHER PRIOR ART

SAH	AR	Castellano et al., "A Survey of Ion Beam Milling Techniques for Piezoelectric Device Fabrication", (1975)
	AS	

Examiner: *[Signature]*

Date Considered: August 27, 2003

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if in conformance and not considered. Include copy of this form with next communication to applicant.